

FIG. 1

FIG. 2 is a perspective view of a device 200 in accordance with the present invention. The device 200 includes a base 210, a top layer 220, and a middle layer 230. The base 210 is a rectangular plate with a central opening 240. The top layer 220 is a rectangular plate with a central opening 240. The middle layer 230 is a rectangular plate with a central opening 240. The device 200 is shown in a perspective view, with the base 210 at the bottom, the top layer 220 at the top, and the middle layer 230 in the middle. The central opening 240 is a rectangular opening in the center of each layer. The device 200 is shown in a perspective view, with the base 210 at the bottom, the top layer 220 at the top, and the middle layer 230 in the middle. The central opening 240 is a rectangular opening in the center of each layer.

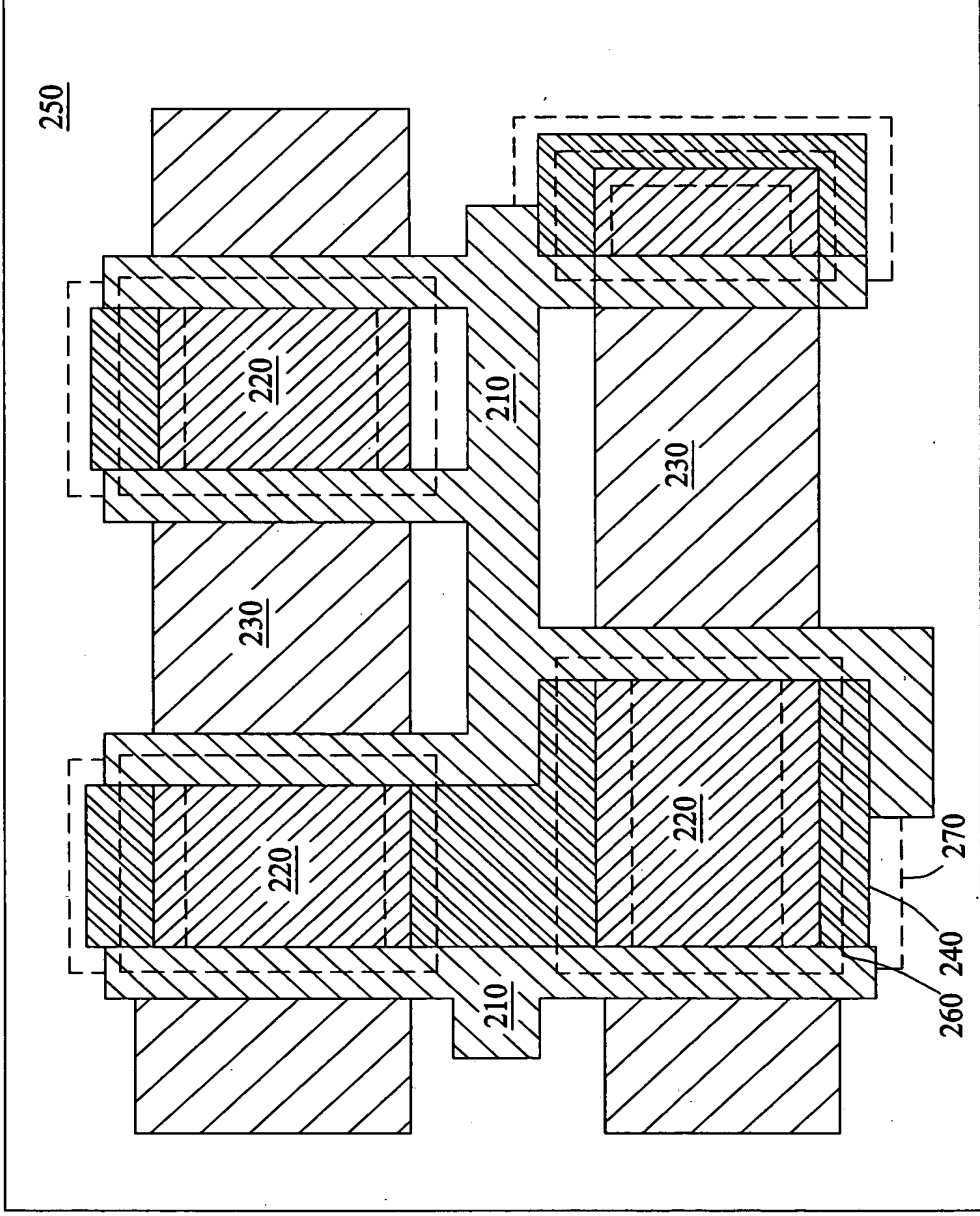


FIG. 2

200

FIG. 3 is a plan view of a substrate 300 having a plurality of openings 310.

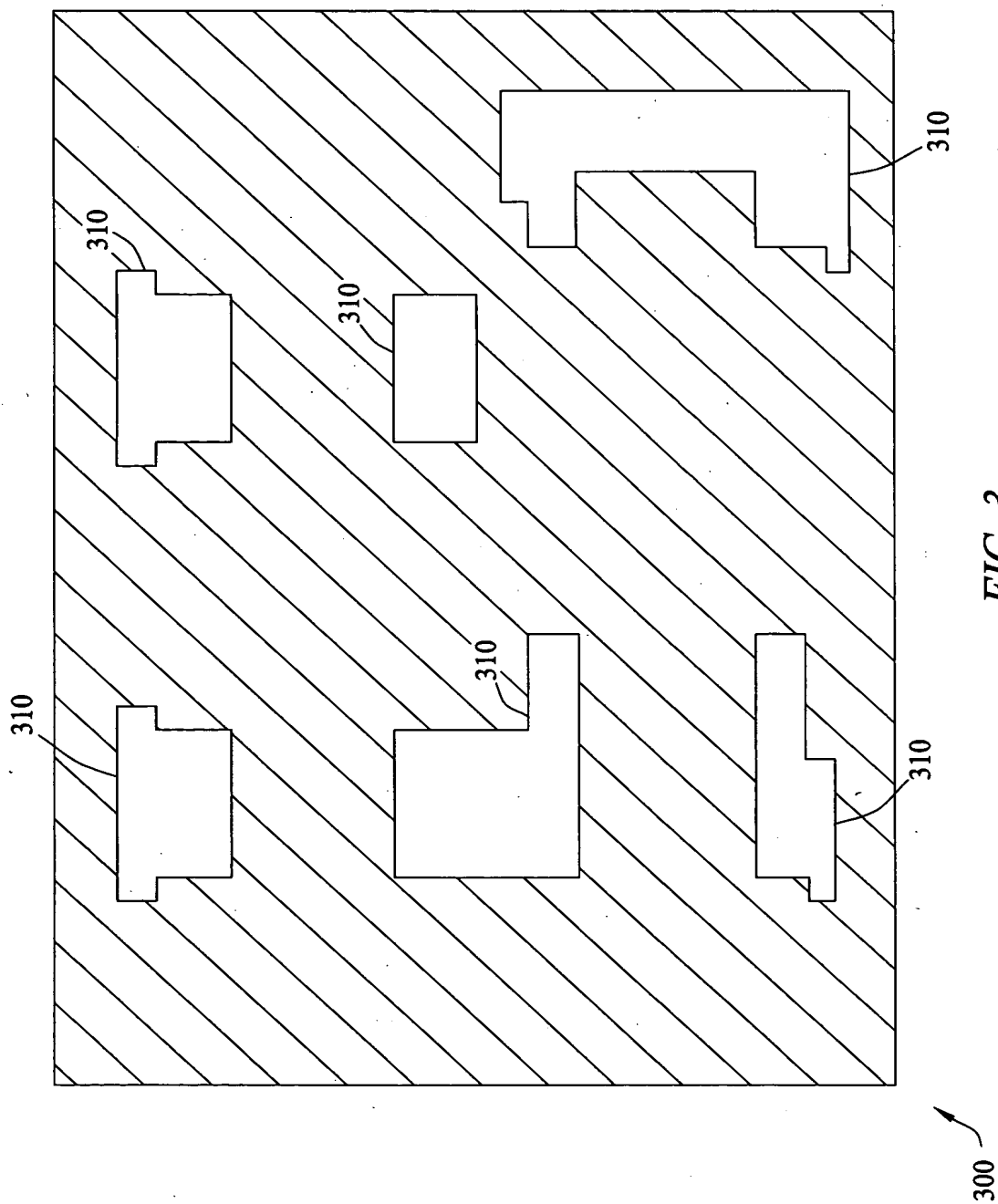


FIG. 3

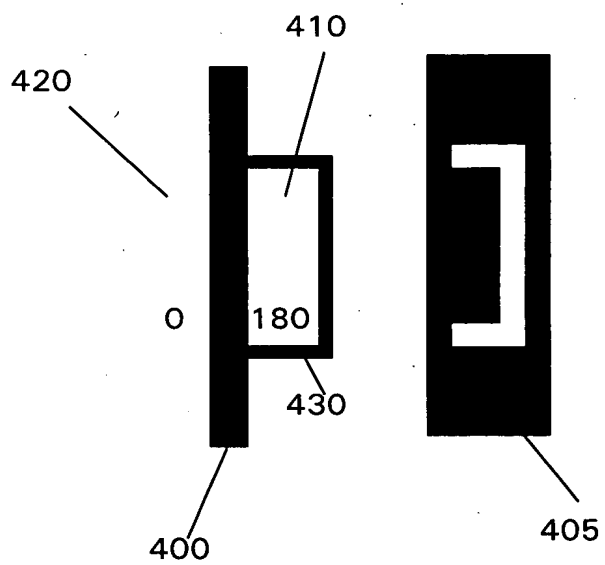


FIG. 4